

<b>Notice of References Cited</b>		Application/Control No. 10/596,415	Applicant(s)/Patent Under Reexamination VAN BOMMEL ET AL.	
		Examiner ANDREW BOWMAN	Art Unit 1792	Page 1 of 1

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	M	US-			

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	V	Martin et al., Fabrication and Application of Hydrogel Stampers for Phisisorptive Microcontact Printing, Langmuir, 2000, 16, pp. 9944-9946			
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.